

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Kenji ADACHI, et al.

Serial Number: Not Yet Assigned

(§371 of International Application PCT/JP03/07529)

Filed: December 8, 2004

For: ROOM-TEMPERATURE MOLTEN SALT, PROCESS FOR PRODUCING

THE SAME AND APPLICATIONS THEREOF

#### **INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

December 8, 2004

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449 and cited in the enclosed international search report.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. <u>01-2340</u>.

Respectfully submitted,

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Enclosures: PTO-1449; International Search Report

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	Applicant(s): Kenji ADACHI, et al.			
PTO-1449	Filing Date: December 8, 2004	Group Art Unit: Not Yet Assigned		

#### **U.S. PATENT DOCUMENTS**

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
	AA						
	AB						
	AC						
	AD						

## FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
AE	1213776 A2	06/12/02	EP	Cited in the International Search Report
 AF	2002-110230	04/12/02	Japan	Cited in the International Search Report
 AG	2001-243995	09/07/01	Japan	Cited in the International Search Report
AH	9-316045	12/09/97	Japan	Cited in the International Search Report
AI	2003-123791	04/25/03	Japan	Cited in the International Search Report

## **OTHER DOCUMENTS**

	AJ / AK	H. Every, et al.; "Ion diffusion in molten salt mixtures;" <i>Electrochimica Acta</i> ; Vol. 45; Issues 8 to 9; 2000; pp. 1279-1284.
Examiner		Date Considered